Supporting Information for

Transition from Schottky to Ohmic Contacts in 2D Ge/GaAs Heterostructure with High Tunneling Probability

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Fig. S1 The total energies (E_{tot}) of Germanene, GaAs monolayer, Ge/(GaAs)_{Ga} heterostructure, and Ge/(GaAs)_{As} heterostructure with different k-point mesh (a) and energy cutoff (b).



Fig. S2 The most energetically favorable stacking configuration of (a) Germanene monolayer, (b) GaAs monolayer, (c) $Ge/(GaAs)_{Ga}$ heterostructure, (d) $Ge/(GaAs)_{As}$ heterostructure.

Fig. S3 The binding energies for Ge/GaAs heterostructures under different layer distance (a) $Ge/(GaAs)_{Ga}$ heterostructure, (b) $Ge/(GaAs)_{As}$ heterostructure.

Fig. S4 The strain energies for Ge/GaAs heterostructures under different biaxial strain (a) $Ge/(GaAs)_{Ga}$ heterostructure, (b) $Ge/(GaAs)_{As}$ heterostructure.

Fig. S5 The band structure of Ge/(GaAs)_{Ga} under (a) -2%, (b)0%, (c)4%, (d)12%, strain, of Ge/(GaAs)_{As} under (e) -2%, (f)0%, (g)4%, (h)12% strain. The light green and light brown areas indicate the Φ_e and Φ_h , respectively.

Fig. S6 The electronic properties of Ge/(GaAs)_{As} heterostructure under different biaxial strain (a) The diagram of tensile biaxial strain, (b) The SBH for electron (Φ_e) and hole (Φ_h), (c) The effective masses of electrons and holes, (d) The charge transfer (Δq) and interfacial dipole moment (D_{int}).

Fig. S7 The band structure of $Ge/(GaAs)_{Ga}$ under (a) -0.2 (V/Å), (b) 0 (V/Å), (c) 0.4 (V/Å), (d) 1 (V/Å) electric fields, of $Ge/(GaAs)_{As}$ under (e) -0.2 (V/Å), (f) 0 (V/Å), (g) 0.4 (V/Å), (h) 1 (V/Å) electric fields. The light green and light brown areas indicate the Φ_e and Φ_h , respectively.

Fig. S8 The electronic properties of $\text{Ge}/(\text{GaAs})_{\text{As}}$ heterostructure under different electric fields (a) The diagram of positive electric field, (b) The SBH for electron (Φ_e) and hole (Φ_h), (c) The effective masses of electrons and holes, (d)The charge transfer (Δq) and interfacial dipole moment (D_{int}).

train.												
Ge/(GaAs) _{Ga}												
Strain (%)	-6	-4	-2	0	2	4	6					
W _{TB} (Å)	2.81	2.85	2.89	2.90	2.95	2.96	2.97					
H_{TB} (eV)	2.43	2.38	2.33	2.26	2.23	2.12	2.05					
P_{TB} (%)	1.55	1.64	1.73	1.95	1.98	2.39	2.69					
	Ge/(GaAs) _{As}											
Strain (%)	-6	-4	-2	0	2	4	6					
W _{TB} (Å)	1.37	1.42	1.51	1.53	1.46	1.53	1.54					
H_{TB} (eV)	0.94	0.96	0.98	1.03	0.92	0.91	0.89					
P_{TB} (%)	32.43	31.01	29.15	27.14	32.05	31.60	32.29					

Table S1 The computed tunneling barrier width (W_{TB}), tunneling barrier height (H_{TB}), and tunneling probability of carriers (P_{TB}) of Ge/GaAs heterostructure under different strain.

Table S2 The computed tunneling barrier width (W_{TB}), tunneling barrier height (H_{TB}), and tunneling probability of carriers (P_{TB}) of Ge/GaAs heterostructure under different electric field.

Ge/(GaAs) _{Ga}											
Electric field (V/Å)	-0.6	-0.4	-0.2	0	0.2	0.4	6				
W_{TB} (Å)	2.39	2.84	2.87	2.90	2.91	2.93	2.94				
H_{TB} (eV)	1.98	2.33	2.30	2.26	2.25	2.23	2.21				
P_{TB} (%)	4.36	1.80	1.85	1.94	1.97	2.01	2.07				
Ge/(GaAs) _{Ga}											
Electric field (V/Å)	-0.6	-0.4	-0.2	0	0.2	0.4	6				
W_{TB} (Å)	1.67	1.63	1.55	1.53	1.49	1.48	1.50				
H_{TB} (eV)	1.08	1.05	1.04	1.03	1.03	1.03	1.03				
P_{TB} (%)	24.0	25.3	26.5	27.1	27.6	27.7	27.5				